04645.0896

12/15/2003 HLE333 00000106 10037133

01 FC:1806

180.00 OP

In re application of

Certificate of Facsimile Transmission

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Michael F. Scalise

DEC 1 2 2003

December 12, 2003

Signature

Date of Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

: Takeuchi et al.

Serial No. : 10/037,133

Filed : December 27, 2001

For : Silver Vanadium Oxide Having

Low Internal Resistance And

Method Of Manufacture

Examiner : C. Chaney

Art Unit : 1745

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.56

Assistant Commissioner for Patents Alexandria, VA 22313-1450

1. Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR 1.56.

The filing of this Information Disclosure Statement (IDS) shall not be construed as a representation that a search has been made (37 CFR 1.56(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

04645.0896

The filing of this IDS shall not be construed as an admission against interest in any manner (Notice of Jan. 9, 1992, 1135 O.G. 13-25, at 25).

- 2. Attached is Form PTO-1449. The relevance of the Leising et al. publication is thoroughly discussed in the accompanying amendment.
- 3. Enclosed is the fee for submission of an Information Disclosure Statement under 37 CFR 1.17(p).
- 4. The person making this statement is the agent who signs below, who makes this statement on the information supplied by the inventors and the information in the agent's file.

Respectfully submitted,

By

Michael F. Scalise Reg. No. 34,920

WILSON GREATBATCH TECHNOLOGIES, INC. 10,000 Wehrle Drive Clarence, New York 14031 (716) 759-5810 December 12, 2003

T2

Cite

No. 1

Examiner

Initials*

Please t	vpe a plus sign inside this box +	PTO/SB/08B(08/00) Approved for use thr	ough 10/31/2002, OMB 0651-0031
			Application Number	10/037,133
1	INFORMATION DISC	CLOSURE PLICANT Application Number Filing Date First Named Inventor Group Art Unit	January 21, 2002	
INFORMATION DISCLO STATEMENT BY APPLI (Use as many sheets as necessar		First Named Inventor	Takeuchi et al.	
1			Group Art Unit	1745
ļ	(Use as many sheets as nec	essary)	Examiner Name	C. Chaney
Sheet	3	of 3	Attorney Docket Number	04645.0869

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate,

title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s),

volume-issue number(s), publisher, city and/or country where published.

SOLID-SATE SYNTHESES AND CHARACTERIZATION OF SILVER VANADIUM OXIDE FOR USE

	AS A CATHODE MATERIAL FOR LITHIUM BATTERIES-Randolph A. Leising and Esther S. Takeuchi-Chemistry of Materials, 1994, 6.	
	Date	
Examiner Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Burden Hour Statement: The form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. Send to the Assistant Commissioner for Patents, Washington, DC 20231.

¹ Unique citation designation number. 2 Applicant is to place a check mark here if English Translation is attached.